

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	9	(("4956619") or ("5600383") or ("6038056") or ("5631782") or ("6413793") or ("5510915") or ("5537234") or ("5737052") or ("6348991")).PN.	USPAT	OR	OFF	2005/05/17 12:43
L2	92	359/290,291,292,295,223,224, 245,248,320,332.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and state\$1 and ((mirror\$2 or micromirror\$3) same stop\$5)	USPAT	OR	OFF	2005/05/17 12:44
L3	284	359/290,291,292,295,223,224, 245,248,320,332.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and state\$1	USPAT	OR	OFF	2005/05/17 12:44
S1	4	(("6,700,693") or ("6,710,906") or ("6,445,486") or ("6,262,832")).PN.	USPAT	OR	OFF	2005/01/27 11:04
S2	1	("20040233500").PN.	US-PGPUB	OR	OFF	2005/01/31 10:48
S3	0	method.ti. and fabricating.ti. and micromirror.ti.	USPAT	OR	OFF	2005/01/31 10:50
S5	3	method.ab. and fabricating.ab. and micromirror.ab.	USPAT	OR	OFF	2005/01/31 11:03
S6	0	method.ti. and fabricate.ti. and micromirror.ti.	USPAT	OR	OFF	2005/01/31 10:50
S7	0	method.ti. and fabricating.ti. and micromirror.ti.	USPAT	OR	OFF	2005/01/31 10:50
S8	9	(("4956619") or ("5600383") or ("6038056") or ("5631782") or ("6413793") or ("5510915") or ("5537234") or ("5737052") or ("6348991")).PN.	USPAT	OR	OFF	2005/01/31 10:56
S9	5	fabricating.ab. and micromirror.ab.	USPAT	OR	OFF	2005/01/31 11:03
S10	1	("20040233500").PN.	US-PGPUB	OR	OFF	2005/01/31 16:28
S11	30	("3766205" "4402573" "4853471" "4902108" "5032498" "5140455" "5151816" "5239406" "5457564" "5679283" "5724187" "5770114" "5818636" "5859722" "5910854" "5998617" "6002511" "6020987" "6141137" "6154306" "6183878" "6187845" "6188505" "6193912" "6241916" "6262832" "6277307" "6301038" "6445486").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/01/31 18:45

S12	1218	"359"/\$.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and state\$1	USPAT	OR	OFF	2005/05/15 19:24
S13	262	"359"/\$.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and (two with state\$1)	USPAT	OR	OFF	2005/05/16 18:46
S14	124	"359"/\$.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and (two with state\$1) and angle\$1 and degree	USPAT	OR	OFF	2005/05/16 13:11
S15	91	"359"/\$.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and (post with ((polycrystalline near silicon) or (monocrystalline near silicon) or (amorphous near silicon) or Aluminum or Mo or W or (Ti "Si.sub.2") or (Co "Si.sub.2") or ("Ti.sub.N") or Cu))	USPAT	OR	OFF	2005/05/15 22:18
S16	35	"359"/\$.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and (post with ((polycrystalline near silicon) or (monocrystalline near silicon) or (amorphous near silicon) or Aluminum or Mo or W or (Ti "Si.sub.2") or (Co "Si.sub.2") or ("Ti.sub.N") or Cu)) and (post same (material or made))	USPAT	OR	OFF	2005/05/16 11:24
S17	0	"359"/\$.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and (post with (polycrystalline near silicon)) and doped	USPAT	OR	OFF	2005/05/16 11:37
S18	0	post\$2 and (mirror\$1 or micromirror\$1) and (post with (polycrystalline near silicon)) and doped	USPAT	OR	OFF	2005/05/16 11:37
S19	0	"359"/\$.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and (post with (polycrystalline near silicon)) and doped	USPAT	OR	OFF	2005/05/16 11:37
S20	0	post\$2 and (mirror\$1 or micromirror\$1) and (post with (polycrystalline near silicon)) and doped	USPAT	OR	OFF	2005/05/16 11:37
S21	0	post\$2 and (mirror\$1 or micromirror\$1) and (post with (polycrystalline near silicon)) and doped	US-PGPUB; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/05/16 11:37
S22	556	"359"/\$.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and (state\$1) and angle\$1 and degree	USPAT	OR	OFF	2005/05/16 13:11

S23	1218	"359"/\$.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and state\$1 and ((mirror\$2 or micromirror\$3) stop\$5)	USPAT	OR	OFF	2005/05/16 18:47
S24	241	"359"/\$.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and state\$1 and ((mirror\$2 or micromirror\$3) same stop\$5)	USPAT	OR	OFF	2005/05/17 12:44
S25	115	"359"/\$.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and state\$1 and (mirror\$2 or micromirror\$3) and (semiconductor\$2 with (micromirror\$ or mirror\$1))	USPAT	OR	OFF	2005/05/16 21:59
S26	1	"359"/\$.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and state\$1 and (mirror\$2 or micromirror\$3) and (semiconductor\$2 with (micromirror\$ or mirror\$1)) and (semiconductor with dioxide)	USPAT	OR	OFF	2005/05/16 22:32
S27	34	"359"/\$.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and state\$1 and (mirror\$2 or micromirror\$3) and (semiconductor\$2 with (micromirror\$ or mirror\$1)) and (silicon with dioxide)	USPAT	OR	OFF	2005/05/17 12:10